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Date: 11/24/03

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT EXAMINING OPERATION

Applicant: Glocker et al.

Serial No.: N/A

Filed: Concurrently herewith

Title: SYSTEM FOR UNBALANCED MAGNETRON SPUTTERING WITH AC

POWER

Examiner: N/A Art Unit: N/A

Docket: 181116CIP

Mail Stop Patent Applications Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DESCLOSURE STATEMENT

Dear Sir:

Pursuant to 37 CFR §§ 1.97 and 1.98, Applicant hereby bring to the attention of the United States Patent and Trademark Office, the enclosed items listed on the Attached PTO-1449 Form. If any additional fees are required, please charge Deposit Account 08-0865.

Respectfully submitted,

Neal L. Slifkin

Attorney for Applicant Registration No.: 34, 018

HARRIS BEACH LLP 99 Garnsey Road Pittsford, New York 14534 (585) 419-8636 (585) 419-8816 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Substitu	te for form 1449A/PTO			Complete if Known			
				Application Number			
INF	ORMATION D	ISCLO	SURF	Filing Date		·· · · ·	
STATEMENT BY APPLICANT				First Named Inventor	David A Glocker		
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	(Use as many sheets a	s necessarv)		Examiner Name			
Sheet	1	of	1	Attorney Docket Number			

Examiner	Cite	Document Number	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where
Initials*	No. ¹	Number-Kind Code ^{2 (il known)}	MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear
		^{US-} 4,041,353	08/09/1977	Penfold et al.	
		l ^{us-} 4,116,795	09/26/1978	De Jong	
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		US-			

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code 3-Number 4- Kind Code 5 (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶	
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				Application Number			
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STATE	STATEMENT BY APPLICANT			First Named Inventor	David A Glocker		
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Sheet	1	of	1	Attorney Docket Number			

NON PATENT LITERATURE DOCUMENTS						
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²			
		B. WINDOW AND N. SAVVIDES, "Charged Particle Fluzes From Planar Magnetron Sources," J. Vac. Scl. Technol. A4, American Vacuum Society (Sydney, Australia), 1986 Mar/Apr p. 196-202,				
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